



Inventor Name Search Result

Your Search was:

Last Name = TAKEUCHI

First Name = YUUICHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>11105587</u>	Not Issued	030	04/14/2005	METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE HAVING TRENCH IN SILICON CARBIDE SEMICONDUCTOR SUBSTRATE	TAKEUCHI, YUUICHI
<u>10824497</u>	Not Issued	030	04/15/2004	METHOD OF MANUFACTURING SILICON CARBIDE SEMICONDUCTOR DEVICE	TAKEUCHI, YUUICHI
<u>10630978</u>	6853006	150	07/31/2003	SILICON CARBIDE SEMICONDUCTOR DEVICE	TAKEUCHI, YUUICHI
<u>10378916</u>	Not Issued	161	03/05/2003	EGR VALVE	TAKEUCHI, YUUICHI
<u>08745958</u>	5723376	150	11/07/1996	METHOD OF MANUFACTURING SIC SEMICONDUCTOR DEVICE HAVING DOUBLE OXIDE FILM FORMATION TO REDUCE FILM DEFECTS	TAKEUCHI, YUUICHI
<u>08539380</u>	5698880	150	10/05/1995	A SEMICONDUCTOR DEVICE HAVING A GROOVE WITH A CURVED PART FORMED ON ITS SIDE SURFACE	TAKEUCHI, YUUICHI
<u>08468073</u>	Not Issued	166	06/06/1995	METHOD OF MANUFACTURING SIC SEMICONDUCTOR DEVICE HAVING DOUBLE OXIDE FILM FORMATION TO REDUCE FILM DEFECTS	TAKEUCHI, YUUICHI
<u>08413410</u>	5776812	150	03/30/1995	MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE	TAKEUCHI, YUUICHI

Inventor Search Completed: No Records to Display.



Day : Saturday
Date: 8/6/2005
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Inventor Name Search Result

Your Search was:

Last Name = ENDOU

First Name = TAKESHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
10824497	Not Issued	030	04/15/2004	METHOD OF MANUFACTURING SILICON CARBIDE SEMICONDUCTOR DEVICE	ENDOU, TAKESHI
09650448	Not Issued	061	08/29/2000	LOADER APPARATUS	ENDOU, TAKESHI
09645052	6357820	150	08/23/2000	WORK VEHICLE	ENDOU, TAKESHI

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